Large Area GEM Production at Peking University



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Outline

- PKU-HEP local lab development and setups
- CMS Phase-II GEM upgrade projects and PKU tasks
- Large area GEM assembly and QC tests
 - GE2/1 M5 production and QC tests
 - ME0 production and QC tests
- Summary and Outlook

PKU-HEP Lab development: layout and facilities



PKU-HEP Lab set up: Gas Leak Test

Gas Leak Test platform established and verified with a RPC:







Front and back panel of the updated

leak test system

Arduino + BMP085 + BME280

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PKU-HEP Lab set up: I-V and H/T Test

- A system for automatically monitoring was established using LABVIEW
- The system was functionally tested using a RPC detector.





PKU-HEP Lab test stands



X-ray shielding room With a three-dimensional movable trail inside to fix the chamber for testing



Testing RPC at the cosmic stand

Time resolution

X-ray test chamber



Lab set up: effective gain test scheme



Design and Test of a 10x10cm² GEM detector



- GEM foil from CERN MPT workshop
- Readout board, drift board, frame and high-voltage distributor designed and manufactured locally
- Mastered relevant technologies
- Made preparations for CMS GEM assembly site certification

The certified set up for GEM assembly and test

- Some assembled chambers are sent from CERN for testing procedures
- The final CMS GEM assembly site certification was achieved in 2021-22



CMS phase-II GEM upgrade projects



Project overview and PKU contributions

| GE1/1 GEM | GE2/1 GEM | Inner Ring MEO GEM |
|-----------|-----------|-----------------------|
| | | |

| | GE1/1 GE2/1 | | MEO |
|----------------------------------|--|---|--|
| Numbers* | 288 (=2×36×4) | 288 (=2×18×8) | 216 (=2×18×6) |
| CMS-China Tasks (Led by PKU) | Production and test of all electronic boards(GEB) Participate assembly, test and commissioning at CERN | Design, production and test of all electronic boards(GEB) Assembly and QC of ~1/8 GEM detectors at PKU, Participate assembly, test and commissioning at CERN Production of external frames, mechanical structures, etc | Design, production and test of all electronic boards(GEB), Assembly and QC of ~1/5 GEM detectors at PKU, Participate assembly, test and commissioning at CERN Production of external frames, mechanical structures, etc |

* (Total number= #endcap × #module/endcap × #/module)

GEM detector design: GE2/1 and ME0

- Both are using triple-GEM technology
- The full GE2/1 system: 72 chambers (36 per end-cap)
 - 4 triple-GEM modules per chamber = 288 modules in total
 - The chambers are arranged in two layers
- Two different types of chambers

Smal

- On-Yoke= FRONT-type (module types M1-M4)
- Off-Yoke= BACK-type (module types M5-M8)

- ME0 system: 216 chambers (108 per end-cap)
 - 6 triple-GEM modules per stack
 - 18 stacks per endcap
- Harsh environment and limited space
 - Rate Capability: >150kHz/cm2
 - Longevity: Need to survive integrated charge up to $7.9C/cm^2$.



CMS GEM assembly: Glue-less technique



GEM assembly and test schemes





QC2 (ME0 chamer)



short impedance test

GE2/1 M5 assembly at PKU lab(2022-23)

| | 01 | 清洁有机玻璃组装底板 | Γ | | 33 | 在GEM stack上放置上层有机玻璃保护板(注意准五)、护上四个角上各两个螺钉 |
|---|----|---|---|--|------|--|
| | 02 | 拔入内框架准直针 | 1 | | 34 | 拧上中心支撑柱螺钉 (不用太紧) |
| _ | 02 | 插入摆放第一层内框架(3mm厚), T-nuts缺口朝上、朝外, 各边框上标记孔数目 | 1 | | 35 | 拧上四边内框架螺钉 (除了每边角上两个玻璃板固定螺钉) |
| | 03 | 与废极一致 | | | 36 | 創除GEM Stack上有机玻璃保护板边沿外的GEM膜边沿部分 |
| | 04 | 放置中心支撑柱和3mm厚圈 | 1 | | | |
| | | | 1 | | 37 | 清洁漂移板(预装的pull-out没有拧死) |
| | 05 | 在G1GEM膜边沿去除GEM2和GEM3高压接触点 | 1 | | 38 | 把漂移板两侧用铝棒和螺钉固定在安装平台底部铝板上 |
| | 06 | 清洁G1GEM膜 | 1 | | 39 | 抬起GEM Stack、按掉准直针 |
| | 07 | 用Megger测试G1 GEM膜 | 1 | | 40 | 把GEM Stack移到漂移板上、注意准直 |
| _ | 00 | 放置G1 GEMile、准直针对准G1 GEMile边沿孔、可稍稍用工具调整准直针方向 | 1 | | 41 | 在側面安装pull-out的张力螺钉(先安装高压一侧、不要太紧) |
| | 00 | 使穿出 | | | 42 | 松开两侧铅棒、移动探测器至底面一边悬空、从底下用扭矩扳手紧死pull-out安装螺钉 |
| | 09 | 割断G1GEM膜和边框粘接胶带、移除边框 | 1 | | 43 | 把读出板放回原来位置,两侧固定 |
| | 10 | 用绿胶带粘上G1 GEM膜边沿,对面两人同时操作拉平(~16个粘接点) | 1 | | 44 | 卸下上层保护板角上固定螺钉,在原位西安装好内框架螺钉 |
| | 11 | 用Megger测试G1 GEM膜、并在有机玻璃组装底板接触点测试G1 GEM膜 | 1 | | 45 | 用12cNm扭矩扳手拧动pull-out倒面张力螺钉,拉紧GEM膜 |
| | | | 1 | | 46 | 清洁两面安装了O圈的边框。放置、麦住GEM Stack |
| | 12 | 在中心支撑柱放员1mm厚圈 | 1 | | 47 | 用漂移板接触点检测GEM膜 |
| | 13 | 在G1GEM上放西第二层内框架((1mm厚), T-nuts缺口朝外 | 1 | | | |
| | 14 | 在G2 GEM膜边沿去除GEM1和GEM3高压接触点 | 1 | | 48 | 清洁读出版,检查气喘 |
| | 16 | 清洁G2 GEM膜 | 1 | | 49 | 卸下保护板中心孔螺钉,移开保护板 |
| | 16 | 用Megger测试G2 GEM膜 | 1 | | 60 | 把读出板移到GEM Stack上、注音准直 |
| | 17 | 放置G2 GEM膜、准直针对准膜边沿孔、可稍稍用工具调整准直针方向使穿出 | 1 | | 61 | 拧上读出板上中心支撑柱螺钉 |
| | 18 | 割断G2 GEM膜和边框粘接胶带、移除边框 | 1 | | 52 | 拧上读出板四边pull-out安装螺钉 (每个pull-out上两个螺钉可协调安装) |
| | 19 | 用绿胶带粘上G2 GEM膜边沿.对面两人同时操作拉平(~16个粘接点) | 1 | | | |
| 0 | 20 | 用Megger测试G2 GEM膜、并在有机玻璃组装度板接触点测试GEM1和GEM2 | 1 | | 53 | 用1.2Nm扭矩扳手紧死所有螺钉(注意不要有遗漏) |
| | | | 1 | | 54 | 用漂移板接触点检测GEM膜 |
| | 21 | 在中心支撑柱放置2mm厚面 | 1 | | 55 | 插上进接两个气喘的保护气管 |
| | 22 | 在内框架槽上插入T-nuts. 用工具压平 | 1 | 组装完成! | | |
| | 23 | 在G2 GEM上放西第三层内框架(2mm厚),T-nuts缺口船下、船外 | 1 | (注音事项) | | |
| | 24 | 在G3 GEM膜边沿去除GEM1和GEM2高压接触点 | 1 | A second se | | |
| | 25 | 清洁G3 GEM膜 | 1 | > 如果感到很难行上、小愛无行死个別感到、愛訪同行上、一起放死。程章: 細行上於螺結果不好(保全統(3)) | | |
| | 26 | 用Megger测试G3 GEM膜 | 1 | 取り上的取益定省が(低少信点) 取出 Aut L 的研究是不明性 (茶達体室) | | |
| | 27 | 放置G3 GEM膜,准直针对准膜边沿孔,可稍稍用工具调整准直针方向使穿出 | 1 | Point Vol.L ID 年(0)と目 (1)(小 (自然) (1)() ・ 是否准言者问题((管論情况)) | | |
| | 28 | 創新G3 GEM膜和边框粘接胶带、移除边框 | 1 | | - 1 | 更接相坏的零件。 |
| | 29 | 用绿胶带粘上G3GEM膜边沿,对面两人同时操作拉平(~16个粘接点) | 1 | 如果所有零件正常、但仍然拧不上、可能孔中残留金属碎屑。 | | |
| | 30 | 用Megger测试G3 GEM模。并在有机玻璃组装底板接触点测试三层GEM膜 | 1 | → 试试用吸尘器把碎屑吸出来。 | | |
| | | | 1 | 1 | 28.0 | 生山心测眠红,脉动下量有机接着促进板时要结束小心,不要感到促进触到。 |
| | 31 | 在中心支撑柱放西1mm厚圈 | 1 | 11 | | A strain the strain the strain st Strain strain stra |
| | 32 | 在G3GEM上放西第四层内框架(1mm厚,无T-nuts缺口) | 1 | 1 | -19 | 答 爱摄到底。 |
| | | | | | | |

GEM探测器组装步骤



Assembly check list





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Mount rea

boa



1st batch of 10 ME0 assembly(Aug-Oct, 2024)



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MEO assembly : 1st batch of 10 chambers

- Assembly and QC test of the first batch of ME0 is completed.
- All the ME0 GEMs will be sent back to CERN for further testing.
- Preparation for the next batch of ME0 is going on.



QC of assembled ME0: gas leakage







criteria: decrease < 7mbar/h (τ>3.7h)

QC of assembled ME0: I-V



QC of assembled ME0: effective gas gain



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Summary and outlook

- To match the CMS Phase-II GEM upgrade projects, a local GEM lab has been set up in PKU and certified as one of CMS-GEM production sites.
- Several batches of GE2/1 M5 and ME0 chambers have been successfully assembled and tested.
- Beyond CMS upgrade, there are some other related activities on gaseous detectors at PKU
 - Muon tomography with RPCs and GEMs
 - TPC as active target for nuclear reaction studies
 - Searching for exotic dark matter and beyond: PKMu proposal

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